

Search Notes 	Application/Control No. 10/045,757	Applicant(s)/Patent under Reexamination STEVENS, RICK C.
Examiner Shi K. Li	Art Unit 2633	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
398	19	11/30/05	sh
398	45	11/30/05	sh
Interference search history printout		11/30/05	sh